

Application No. 10/700,516 Docket No. 740756-2666

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)	
Shunpei YAMAZAKI et al.)	Examiner: Stephen Smooth
Serial No. 10/700,516)	Group Art Unit: 2813
Filed: November 5, 2003)	_
For: Laser irradiation apparatus and metho	DD)	
OF FABRICATION SEMICONDUCTOR DEVICE)	
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CORRECTED INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Further to the IDS filed September 29, 2005, Applicants submit herewith a corrected form PTO-1449. It is noted that US2003/0129790A1 to Yamazaki et al. (published July 10, 2003) was incorrectly listed in the previously filed form PTO-1449 as US2003/012790.

Applicants sincerely appreciate the Examiner bringing this typographical error to Applicants' attention and allowing Applicants an opportunity to rectify the error.

Respectfully submitted,

By: _

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Sheet

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

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of

Complete if Known		
Application Number	10/700,516	
Filing Date	November 5, 2003	
First Named Inventor	Shunpei YAMAZAKI et al.	
Art Unit	2813	
Examiner Name	Yennhu B. Huynh	
Attorney Docket Number	740756-2666	

U.S. PATENT DOCUMENTS						
Examiner Initials	Cite No.¹	U.S. Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
		Number - Kind Code ² (if known)				
		US-2003/0129790 A1	07/10/2003	Yamazaki et al.		
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FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	Foreign Patent Document Kind Code ³ Country Code ³ Number ⁴ (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Application of Cited Document	Pages, Cohumns, Lines, Where Relevant Passages or Relevant Figures Appear	T⁵
		JP2004-039890 A	02/05/2004	Yamazaki		AB
		JP2004-179356 A	06/24/2004	Yamazaki et al.	·	AB
		JP2004-289140 A	10/14/2004	Moriwaka et al.		AB
		OTHER PRIOR A	ART – NON PATENT I	LITERATURE DOCUMENTS		
Examiner Initials*	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.)., date, page(s), volume-issue number(s), publisher, city and/or country where published.				
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Examiner	Date
Signature	Considered

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

¹ Applicant's unique citation designation number (optional). ² Applicant is to place a check mark here if English language Translation is attached.